



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the **PATENT APPLICATION** of:

Cheng et al.

Application No.: 09/925,356

Confirmation No.: 4334

Filed: August 9, 2001

For: PROCESS OF FORMING FIELD
EMISSION ELECTRODE FOR
MANUFACTURING FIELD EMISSION
ARRAY

Group: 2879

Examiner: Adolfo Nino

Our File: DEE-PT028

Date: September 16, 2003

REPLY PURSUANT TO 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 18, 2003. A
petition for a three-month extension of time is enclosed herewith.
application as follows: